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CLASS	ISSUE CLASS
586	

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.	PATENT DATE
SCANNED HKM3 OA 10/3 HKM2	

APPLICATION NO. 09/887777	CONT/PRIOR D	CLASS 586	SUBCLASS 75	ART-UNIT 152 663	EXAMINER Hassan Brophy
APPLICANTS R. Doak Christopher Burns Dirk Jordan					
TITLE Method and apparatus for preparing nitride semiconductor surfaces					

118 723FE

PTO-2040
12/99

ISSUING CLASSIFICATION							
ORIGINAL				CROSS REFERENCE(S)			
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
INTERNATIONAL CLASSIFICATION							

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	(Assistant Examiner) (Date)			NOTICE OF ALLOWANCE MAILED	
	(Primary Examiner) (Date)			ISSUE FEES Amount Due Date Paid	
	(Legal Instruments Examiner) (Date)			ISSUE BATCH NUMBER	

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